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Design Analysis of Integrated Passive Device-Based Balun Devices With High Selectivity for Mobile Application

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ABSTRACT This paper presents highly selective, low-loss, and miniaturized balun devices fabricated using the integrated passive device (IPD) technique for the GSM band (900/1800 MHz) and the WiFi band (2400 MHz) in mobile applications. Balun devices were fabricated on a gallium arsenide (GaAs) substrate using the IPD fabrication process to reduce the overall size $(0.05\lambda_g \times 0.036\lambda_g \text{ at } 900 \text{ MHz})$. Each device is the combination of lattice lumped structure with a low-pass filter and a high-pass filter configuration. This structural formation of lumped elements helps to reduce the phase mismatch error in the balun devices. For all the balun devices, the measured results indicated a minimum amplitude imbalance (<0.47 dB) and low phase imbalance (180 ± 2.6°). Mathematically calculated, calculated after considering parasitic effects, simulated and measured results exhibited a good correlation. The return loss is below 18 dB and insertion loss is below 0.25 dB for the entire fabricated devices. A balun device with a center frequency of 900 MHz has given the best results amongst all fabricated devices.

INDEX TERMS Integrated passive device (IPD), gallium arsenide (GaAs), MIM capacitor, spiral inductor.

I. INTRODUCTION

Balun is a vital component that works as subordinate for numerous microwave devices requiring differential signal. It isolates input signal into two output signal each with half amplitude and 180° phase shift [1], [2]. The basic purpose of balun is to transfer signal in-between two diverse transmission environments with minimal power loss [3]. In the circuit level, balun has been used with several devices such as double balanced mixers, frequency multipliers, antennas, and push-pull amplifiers [4]–[8]. Several passive balun designs such as Marchand type [9], [10], Wilkinson type [11], [12], hybrid type [13], [14], lumped-element type [15], [16], and microstrip type [17], [18] have been previously reported. Balun design concepts are broadly classified into distributed and lumped form. The distributed type balun devices are the combination of quarter wavelength coupled line resonators. These types of balun devices acquire large bandwidth and correlated phase [19]. But they occupy large area at low frequencies (<5 GHz) due to quarter-wavelength coupled lines [20], [21]. Similarly, the lumped type balun devices are constructed using multiple units of lattice resistor (R), inductor (L) and capacitor (C) structure or low pass filter (LPF) and high pass filter (HPF) lumped element structures [22]. These types of balun devices require small area as compared to distributed type but they exhibit high losses, narrow bandwidth and large phase imbalance [23]. Since, most conventional microwave passive component designs are based on transmission line concept and they occupy large area. Due to the problem of acquiring large area at low frequencies, they have become a bottleneck problem for the size reduction in microwave front-end [24]. Various works have been proposed

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to reduce the structure size of microwave passive component design. Currently, lattice type balun design based on symmetrical π -structure of lumped elements in low and high pass filter configuration has become a good candidate for microwave passive device designs due to its compact layouts and small size [15], [25]. The introduction of the capacitive component along with the inductive component helps to increase the overall reactive impedance of the circuit and helps inductor to act as a transformer [26]. Moreover, the combination of LPF and HPF in the design structure can also be used to reduce the phase mismatch error [23]. Although, the minimal structure size achievable at low frequency is usually limited by the fabrication process such as minimum possible fabricated line width and the gap width [27]. Integrated passive device (IPD) fabrication is one of the best possible solutions to produce high-quality and miniaturized size passive devices [28]. Recently, Gallium Arsenide (GaAs) substrate based IPD technology has been considered as a best candidate for lumped element implementation due to its high substrate resistivity and low substrate loss [29], [30]. The high resistivity of a substrate helps to reduce coupling losses between lumped components, suppresses substrate noise, and minimizes parasitic effects such as stray capacitance and stray inductance at high frequency [31]. Low loss substrate helps to minimize eddy current loss and increase Q value of lumped elements [32]. The fabricated devices using IPD technique also shows good compatibility to integrate into the systemin-package or system-on-chip environment using multichip modules (MCMs) [28].

In this paper, we presented three highly selective, low loss and miniaturized lumped element based balun devices fabricated through IPD technology on GaAs substrate for different center frequencies.

Design analysis of individual balun device is evaluated after comparing the mathematically calculated, calculated with parasitic effects, simulated and fabricated results. The fabricated balun structures are suitable for telecom industries, where miniaturization and integration are necessary. The compact dimensions of balun devices are $1.2 \text{ mm} \times 1.8 \text{ mm} \times$ 0.2 mm, $1 \text{ mm} \times 1.5 \text{ mm} \times 0.2 \text{ mm}$ and $1 \text{ mm} \times 1.4 \text{ mm} \times$ 0.2 mm at center frequency of 900 MHz, 1800 MHz and 2400 MHz, respectively.

II. MATHEMATICAL ANALYSIS

The proposed balun devices are based on lattice structure of lumped type *LC* elements placed in LPF and HPF configuration, where, $L_1 = L_2$ and $C_1 = C_2$. The circuit configuration of lumped element based balun device in π -network is shown in Fig. 1(a). To achieve better impedance matching and minimum phase imbalance the output ports of this configuration are formed quarter wavelength apart [33], [34]. The transmission or ABCD parameters for an ideal lossless transmission line (attenuation, $\alpha = 0$) is written as [35],

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} \cos\beta l & jZ_0 \sin\beta l \\ jY_0 \sin\beta l & \cos\beta l \end{bmatrix}$$
(1)



FIGURE 1. (a) Basic π-type circuit of lumped type balun device. (b) Compensated circuit of lumped type balun device.

where,

- Z₀ represents characteristic impedance
- β represents wave phase shift per unit length
- *l* represents length of transmission line

Y₀ represents characteristic admittance of transmission The output ports of balun device can be represented with quarter-wave and odd multiples of quarter-wave transmission line. The output ports of the lumped circuits are formed $\lambda/4$ and $3\lambda/4$ apart, that makes $\beta l = 90^{\circ}$ and 270° [36]. After substituting the value of βl , (1) can be rewritten as: when, $\beta l = 90^{\circ}$

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 0 & jZ_0 \\ jY_0 & 0 \end{bmatrix}$$
(2)

and when $\beta l = 270^{\circ}$

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 0 & -jZ_0 \\ -jY_0 & 0 \end{bmatrix}$$
(3)

For quarter-wave transformer,

$$Z_0 = \sqrt{Z_{in} Z_L} \tag{4}$$

To simplify analysis, ABCD parameter is applied to the individual arm of the presented balun circuit in Fig. 1(b). Series inductor can be represented as.

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & jX_L \\ 0 & 1 \end{bmatrix}$$
(5)

Similarly, shunt capacitor can be represented as,

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & 0 \\ jB_C & 1 \end{bmatrix}$$
(6)

Moreover, series capacitor can be represented as,

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & -jX_C \\ 0 & 1 \end{bmatrix}$$
(7)

Also, shunt inductor can be represented as,

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & 0 \\ -jB_L & 1 \end{bmatrix}$$
(8)

LPF is the combination of series inductor and shunt capacitor in cascaded form. Therefore, the transmission parameter for LPF can be extracted from (5) and (6),

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & jX_L \\ 0 & 1 \end{bmatrix} \begin{bmatrix} 1 & 0 \\ jB_C & 1 \end{bmatrix}$$
(9)

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 - B_C X_L & j X_L \\ j B_C & 1 \end{bmatrix}$$
(10)

where, $X_L = \omega L$ and $B_C = \omega C$

Similarly, HPF is the combination of series capacitor and shunt inductor in cascaded form. Therefore, the transmission parameter for HPF can be extracted from (7) and (8),

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 & -jX_C \\ 0 & 1 \end{bmatrix} \begin{bmatrix} 1 & 0 \\ -jB_L & 1 \end{bmatrix}$$
(11)

$$\begin{bmatrix} A & B \\ C & D \end{bmatrix} = \begin{bmatrix} 1 + jB_L X_C & -jX_C \\ -jB_L & 1 \end{bmatrix}$$
(12)

where, $X_C = \frac{1}{\omega C}$ and $B_L = \frac{1}{\omega L}$. The inductance and capacitance value can be evaluated after comparing (2) with (9) and (3) with (11) respectively,

$$L = \frac{Z_0}{\omega} \tag{13}$$

$$C = \frac{1}{Z_0 \omega} \tag{14}$$

where, $\omega =$ angular frequency

The evaluated value of discrete L and C components extracted from (13) and (14) is shown in Table 1. The input impedance of 50 Ω and output impedance of 300 Ω is considered for calculation purpose. The selected center frequency for the theoretical calculation is based on GSM and broadband services (900 MHz, 1800 MHz and 2400 MHz) in mobile communication.

TABLE 1. Theoretical value of L and C in lumped type balun device.

ſ	^{c a} (MHz)	$Z_{in}(\Omega)$	$Z_{L}\left(\Omega ight)$	$Z_{ heta}(\Omega)$	<i>L</i> (nH)	C(pF)
	900	50	300	122.47	21.66	1.44
	1800	50	300	122.47	10.83	0.72
	2400	50	300	122.47	8.12	0.54
ac	C (F					

 $f_0 = Centre Frequency$

III. DESIGN AND SIMULATION

A. PARASITIC EFFECTS

In microwave frequencies, the lumped elements such as inductor (L), capacitor (C) and resistor (R) suffer from parasitic reactance due to the existing fringing fields. These lumped components such as L and C store or release electric and magnetic fields during their high frequency operations. These released fields act as stray capacitance and inductance inside the circuit and degrade output results. This involvement of unintentionally formed components generates parasitic effect inside the circuit. In IPD devices, the effect of ground plane, substrate material losses and thickness, conductor material losses and thickness, fringing field, proximity effect play an important role for the presence of such parasitic effects. These effects induce shift in the desired



FIGURE 2. Equivalent circuit of lumped element designed by IPD process. (a) MIM capacitor. (b) Spiral inductor.

resonating frequency [37], [38]. It is necessary to analyze the involvement of parasitic effects prior to fabrication of device using IPD technique. The fabricated design is the combination of two on-chip spiral inductors and two metal-insulatormetal (MIM) capacitors in LPF and HPF configuration. The size of spiral inductors is considered small to reduce parasitic losses and increase integration. The reduction in overall parasitic losses in the devices helps to minimize insertion loss and improve return loss [32]. Prior to fabricating the balun devices the value of parasitic effects in MIM capacitor and spiral inductor have been evaluated and replaced with a small circuit of lumped elements. The equivalent circuit for MIM capacitor and spiral inductor is shown in Fig. 2. Furthermore, the ideal value of L and C components discussed in Fig. 1(b) are replaced with the simulated values through NI AWR design environment to realize the actual effect of fabricated spiral inductor and MIM capacitor equivalent circuits of MIM capacitor and spiral inductor shown in Fig. 2 for further analysis. The obtained circuit is in the circuit after fabrication. The equivalent circuit of balun devices after involving the extracted form of lumped element is shown in Fig. 3. The values of the calculated model parameters after considering all the parasitic effects and a design dimension error are shown in Table 2 (a) and (b), respectively.

In model parameter of MIM capacitor, L_{P1} and R_{P1} represent inductance and resistance of lower plate, Cm and Rm represent capacitance and resistance due to dielectric material present in-between conductive plates and finally, L_{P2} and R_{P2} represent inductance and resistance of upper plate. Similarly, in model parameter of spiral inductor, L_m and R_m represent inductance and resistance of conductive metal. Also, $C_{\rm f}$ represents the capacitance effect exists due to the gap present in between conductive spiral lines. The effect of other parameters like co-planar waveguide with ground (CPWG) and transmission line (TML) is also considered during circuit simulation.



FIGURE 3. Equivalent circuit of balun devices including possible design errors.

 TABLE 2. (a) Calculated model parameter value of MIM capacitor.

 (b) Calculated model parameter value of spiral inductor.

(a)								
f_0^{a} (MHz)	$L_{\rm P1}(\rm pH)$	$R_{\rm P1}(\Omega)$	$R_{\rm m}({ m M}\Omega)$	$C_{\rm m}({\rm pF})$	$L_{P2}(pH)$	$R_{ m P2}\left(\Omega ight)$		
900	87.36	0.06	1	2.49	64.84	0.07		
1800	92.80	0.12	1	1.25	67.20	0.14		
2400	83.73	0.11	1	0.92	60.49	0.13		
${}^{a}f_{0}$ = Centre Frequency								
(b)								
f_0^{a} (MHz)			$L_{\rm m}({\rm nH})$	$R_{ m m}(\Omega)$		$C_{\rm f}({ m fF})$		
900			12.49 1.08		19.47			
	1800		6.61 0.66		5	16.98		
2400			4.18 0.46		12.01			

 ${}^{a}f_{0}$ = Centre Frequency





B. SIMULATED DESIGN

The proposed balun devices consist of two spiral inductors with equal number of turns and equal inner diameter. Similarly, two MIM capacitors of similar effective area are used to convert inductor as a transformer [26]. The proposed balun devices were simulated using Advance Design System (ADS) simulation software at center frequencies of 900 MHz, 1800 MHz and 2400 MHz, respectively. The top view and perspective view of the simulated balun device is shown in Fig. 4.

TABLE 3. Dimensions of lumped devices in simulated balun device.

f_0^a	Balun Device		Spiral Inductor		MIM Capacitor	
(MHz)	L ^b (mm)	W ^c (mm)	$D^{d}(\mu m)$	T ^e	$L^{b}(\mu m)$	W ^c (µm)
900	1.8	1.2	150	06	75	100
1800	1.5	1	100	05	75	50
2400	1.4	1	100	04	55	50
$f_{a}^{a} = Center Frequency I^{b} = I ength W^{c} = Width D^{d} = Diameter of Spiral$						

 f_0^* = Center Frequency, L° = Length, W° = Width, D° = Diameter of Spiral, T° = Number of Spiral Turns

The selection of central frequency is based on the dimensions of spiral inductor and MIM capacitor. The inductance value of design is based on the diameter and number of turns of spiral inductor, whereas the capacitance value is based on the effective area of MIM capacitor [38]. The dimensions of simulated and fabricated balun devices along with spiral inductor and MIM capacitor dimensions at different center frequencies is shown in Table 3.

IV. FABRICATION

The IPD fabrication method and steps play a vital role to fabricate an error-free balun device. The following process of IPD fabrication used to fabricate all balun devices. Firstly, a 6 inch GaAs wafer is procured and then cleaned with acetone, Iso-Propyl Alcohol and DI water, respectively. Later on, silicon nitride (Si₃N₄) was deposited on the wafer using plasma enhanced chemical vapor deposition process. Si₃N₄ was used for wafer passivation and to increase the adhesion between wafer and first seed metal layer. Then, photoresist was patterned to form a desired structure on wafer. After that, first seed metal of Ti/Au was deposited via sputtering process and then Cu/Au was deposited using electroplating process. The thickness of total metal was considered as 5 μ m to reduce skin effect loss and make process cost effective. In the next step, dry etching was used to remove undesired seed metal layer and then used acetone to remove unwanted photoresist. Then again Si₃N₄ layer was deposited to prevent shortage between top metal and bottom metal and form an insulator for MIM capacitor.

Another important and complex task was to form air-bridge post. Firstly, photoresist coating was done and then air bridge seed metal of Ti/Au was formed using sputtering followed by the deposition of Cu/Au through electroplating process. Again acetone was used to remove undesired photoresist. Afterwards, reactive-ion-etching was used to remove undesired seed metal part. In last, Si₃N₄ was coated to form final passivation layer. The IPD based balun structure, layer information and cross-sectional focused ion beam (FIB) image of device is shown in Fig. 5.

V. RESULTS AND DISCUSSIONS

To validate the proposed design of baluns, the mathematically calculated, calculated with parasitic effects, simulated and measured S-parameter and phase response of designed balun devices at 900 MHz, 1800 MHz and 2400 MHz are compared. It can be observed from Fig. 6(a) that there is a good correlation between mathematically calculated (MC), calculated after considering parasitic effects (PE), simulated (SM)



FIGURE 5. (a) Layer information of a fabricated a balun device. (b) A fabricated balun device. (c) Cross-sectional view to show formation of lumped elements after IPD fabrication. (d) FIB image of the air-bridge structure.



FIGURE 6. Comparison of calculated, simulated, and measured results at 900 MHz. (a) Magnitude response. (b) Phase imbalance.

and measured (ME) S-parameters. The evaluated S-parameter at 900 MHz shows the amplitude imbalance of 0.02 dB, 0.012 dB, 0.008 dB and 0.002 dB in MC, PE, SM and ME, respectively. Similarly, the phase imbalance of $180 \pm 2.6^{\circ}$ in-between 0.5 - 4 GHz for MC, PE, SM and ME results is shown in Fig. 6(b). The measured results show return loss higher than 25 dB and insertion loss lower than 0.2 dB at 900 MHz.



FIGURE 7. Comparison of calculated, simulated, and measured results at 1800 MHz. (a) Magnitude response. (b) Phase imbalance.

Moreover, the S-parameters, which were evaluated at the central frequency of 1800 MHz and are shown in Fig. 7(a), indicated a good agreement among MC, PE, SM and ME S-parameters with amplitude imbalance of 0.002 dB, 0.29 dB, 0.25 dB and 0.35 dB, respectively. In addition, a good correlation among phase response of balun device operating at 1800 MHz was obtained and is shown in Fig. 7(b). The measured phase imbalance is $180 \pm 2.5^{\circ}$ for the frequency range of 0.5 - 4 GHz. The measured return loss is higher than 18 dB and insertion loss is lower than 0.25 dB at 1800 MHz.

Furthermore, the S-parameters and phase imbalances of a balun (2400 MHz), which are shown in Fig. 8 (a) and (b), indicated a good match among MC, PE, SM and ME with amplitude imbalance of 0.009 dB, 0.35 dB, 0.1 dB and 0.47 dB and phase imbalance of $180 \pm 3^{\circ}$ for a frequency range of 0.5 - 5 GHz. The measured return loss and insertion loss was higher than 21 dB and lower than 0.24 dB, respectively.

Table 4, which compares the various performance parameters of the proposed balun devices with several previously reported baluns, indicates that our developed balun devices have exhibited the smallest amplitude and phase imbalance, which can be attributed to the symmetrically configured LPF and HPF-based layout of the illustrated balun devices. In addition, the proposed baluns have exhibited more

TABLE 4. Performance comparison of the proposed baluns with several reported baluns.

Ref.	f_0^{a} (MHz)	Fabrication	Return Loss (dB)	Insertion Loss (dB)	Amplitude Imbalance (dB)	Phase Imbalance (°)	Effective Area (mm ²)
10	5500	LTCC	Not Available	1.76	0.6	5	$0.089 \ \lambda_g imes 0.076 \ \lambda_g$
14	2200	LTCC	>10	2.26	0.4	3.2	$0.067 \lambda_{g} \times 0.042 \lambda_{g}$
18	2880	PCB	17	5.1	0.49	6.5	$0.1 \lambda_{\rm g} \times 0.1 \lambda_{\rm g}$
19	1000	PCB	19	0.8	0.35	5	$0.586 \lambda_g \times 0.317 \lambda_g$
20	6500-28500	IPD	Not Available	3.69	1	1.65	Not Available
21	4450	IPD	57.9	0.75	0.49	6.2	Not Available
	900		25	0.2	0.002	2.6	$0.05 \lambda_g \times 0.036 \lambda_g$
This work	1800	IPD	18	0.25	0.35	2.5	$0.032 \ \lambda_{\rm g} \times 0.021 \ \lambda_{\rm g}$
	2400		21	0.24	0.45	2.6	$0.04 \lambda_{g} \times 0.028 \lambda_{g}$

 f_0^a = Center Frequency



FIGURE 8. Comparison of calculated, simulated, and measured results at 2400 MHz. (a) Magnitude response. (b) Phase imbalance.

compact size and better selectivity. Moreover, the reduced parasitic loss of the device due to the high-resistivity GaAs substrate and compact on-chip spiral inductor resulted in excellent insertion and return losses.

VI. CONCLUSION

In this paper, highly selective, low-loss and miniaturized balun devices with central frequencies of 900 MHz, 1800 MHz (GSM band) and 2400 MHz (Wi-Fi band) have been proposed, simulated and fabricated using GaAs-IPD technology. The lumped elements-based symmetric LPF and HPF configuration fabricated on a high-resistivity GaAs substrate helps to achieve low insertion loss, minimize phase and amplitude imbalance and miniaturize balun devices. The calculated and simulated results are compared with measured results to indicate fabrication errors. To minimize the fabrication errors in design, all parasitic effects were considered during calculation and simulation. The fabricated balun devices indicated amplitude imbalance of 0.002 dB, 0.35 dB and 0.47 dB and phase imbalance of 2.6°, 2.5° and 2.6° at central frequency 900 MHz, 1800 MHz and 2400 MHz, respectively.

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